Lecture 4: Gate Leakage

CSCE 6933/5933 Advanced Topics in VLSI Systems

Instructor: Saraju P. Mohanty, Ph. D.

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Scaling Trends and Effects: Summary

- Scaling improves
 Transistor Density of chip
 Functionality on a chip
 Speed, Frequency, and Performance
- Scaling and power dissipation
 Active power remains almost constant
 Components of leakage power increase in number and in magnitude.

Gate leakage (tunneling) predominates for sub 65-nm technology.





Energy-Band Diagram Showing Tunneling (Direct Tunneling Occurs when: $V_{OX} < \Phi_{OX}$)



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E. Kougianos and **S. P. Mohanty**, "Metrics to Quantify Steady and Transient Gate Leakage in Nanoscale Transistors: NMOS Vs PMOS Perspective", in *Proceedings of the 20th IEEE International Conference on VLSI Design (VLSID)*, pp. 195-200, 2007.





Outline

- 1. Both ON and OFF state gate leakage are significant.
- 2. During transition of states there is transient effect is gate tunneling current.
- 3. Three metrics: $I_{ON,}$ $I_{OFF,}$ and $C_{tunneling}$
- 4. C_{tunneling}: Manifests to intra-device loading effect of the tunneling current.
- 5. NMOS Vs PMOS in terms of three metrics.
- 6. Study process/supply variation on three metrics.





Salient Point

The metric, effective tunneling capacitance essentially quantifies the intra-device loading effect of the tunneling current and also gives a qualitative idea of the driving capacity of a Nano-CMOS transistor.





Gate Capacitance of a Transistor (Intrinsic)









We propose that transient in gate tunneling current due to state transitions are manifested as capacitances.





Analysis in a Nano-CMOS Transistor





Outline: Nano-CMOS Transistor

- Dynamics of gate oxide tunneling in a transistor
- SPICE model for gate leakage
- ON, OFF, and transition states of a transistor
- Gate leakage in ON, OFF, and transition states of a transistor







- I_{gs}, I_{gd}: tunneling through overlap of gate and diffusions
- I_{gcs}, I_{gcd}: tunneling from the gate to the diffusions via channel
 - Igb: tunneling from the gate to the bulk via the channel

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ON State: NMOS Transistor



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ON State: PMOS Transistor





OFF State: NMOS Transistor



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OFF State: PMOS Transistor



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Transition State: PMOS Transistor



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NMOS Gate Leakage Current (For a Switching Cycle)







PMOS Gate Leakage Current (For a Switching Cycle)







NMOS Vs PMOS: 3 Mechanisms of Tunneling

Three major mechanisms for direct tunneling: 1.electron tunneling from conduction band (ECB) 2.electron tunneling from valence band (EVB) 3.hole tunneling from valance band (HVB)

For NMOS:

•ECB controls gate-to-channel tunneling in inversion
•EVB controls gate-to-body tunneling in depletion-inversion
•ECB controls gate-to-body tunneling in accumulation

For PMOS:

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•HVB controls the gate-to-channel tunneling in inversion
•EVB controls gate-to-body tunneling in depletion-inversion
•ECB controls gate-to-body tunneling in accumulation

PMOS < NMOS: Φ_{OX} for HVB (4.5 eV) is higher than Φ_{OX} for ECB (3.1 eV), the tunneling current associated with HVB is less than that with ECB.



Source: Roy Proceedings of IEEE Feb2003





Three Metrics for Tunneling Current





Gate Leakage: Observation

The behavior of the device in terms of gate tunneling leakage must be characterized not only during the steady states but also during transient states.





Gate Leakage: Metrics

- Gate leakage happens in ON state: I_{ON}
- Gate leakage happens in OFF state: I_{OFF}
- Gate leakage happens during transition: C_{eff}^{tun}





Gate Leakage for a Transistor

Calculated by evaluating both the source and drain components

$$\Box \text{ For a MOS}, \ \mathbf{I}_{ox} = \mathbf{I}_{gs} + \mathbf{I}_{gd} + \mathbf{I}_{gcs} + \mathbf{I}_{gcd} + \mathbf{I}_{gb}$$

Values of individual components depends on states: ON, OFF, or transition





Gate Leakage Current (For a Switching Cycle)







Inverter: Gate Leakage Paths (Putting NMOS and PMOS together)





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We propose to quantify as:

$$C_{eff}^{tun} = \frac{Ion - IoFF}{\left(\frac{dV_g}{dt}\right)}$$
$$= \frac{Ion - IoFF}{VDD} t_r \text{ (for equal rise/fall time)}$$





Effect of Process and Design Parameter Variation





I_{ON} / I_{OFF} Versus T_{ox}: NMOS







I_{ON} / I_{OFF} Versus T_{ox}: PMOS







I_{ON} / I_{OFF} Versus T_{ox}: Inverter







C_{eff}^{tun} Versus T_{ox}: NMOS







C_{eff}^{tun} Versus T_{ox}: PMOS







C_{eff}^{tun} Versus T_{ox}: Inverter







Statistical Analysis of the Metrics




Monte Carlo Simulations: (Modeling Variations)

- Monte Carlo (N=1000) results.
 - 10% variation in gate oxide and supply assumed.







Monte Carlo Simulations: (Modeling Variations)

- All three metrics follow lognormal distribution.
- This is expected since gate T_{ox} and V_{dd} are assumed normally distributed and I_{ox} depends exponentially on both.
- Small parameter variation (10%) leads to large deviance in the metrics (2-3 sigma).





Gate Leakage in Nano-CMOS

- Both ON and OFF states contribute to gate oxide leakage.
- Transient effect is significant and can be captured via effective tunneling capacitance.
- I_{ON} and I_{OFF} metrics to quantify gate leakage current during steady state.
- $C_{tun}^{eff} \equiv$ Effective tunneling capacitance at the input of a logic gate.





S. P. Mohanty and E. Kougianos, "Steady and Transient State Analysis of Gate Leakage Current in Nanoscale CMOS Logic Gates", in *Proceedings of the 24th IEEE International Conference on Computer Design (ICCD)*, pp. 210-215, 2006.





Outline

- 1. Both ON and OFF state gate leakage are significant.
- 2. During transition of states there is transient effect is gate tunneling current.
- 3. New metrics: I_{tun} and C_{tun}
- 4. C_{tun}: Manifests to intra-device loading effect of the tunneling current
- 5. NOR Vs NAND in terms of I_{tun} and C_{tun}
- 6. Study process/design variation on I_{tun} and C_{tun}





Salient Point

A new metric, the effective tunneling capacitance essentially quantifies the intra-device loading effect of the tunneling current and also gives a qualitative idea of the driving capacity of the logic gate.

How to quantify it at transistor and logic-gate level??





Transistor \rightarrow Logic Gate

- How do we quantify the same metrics at logic level??
- State dependent or state independent??





Analysis in Logic Gates





Gate Leakage in 2-input NAND (State Specific)







Gate Leakage in 2-input NAND (State Specific)

 $I_{ox, Logic}(State) = \sum I_{ox, i}$ MOS,i

Four different states for 2-input NAND:

Iox, Logic (State)







Gate Leakage in 2-input NAND (State Independent)

 $I_{tun} \equiv$ State Independent average gate leakage current of a logic gate

$$I_{tun} = \frac{1}{4} (I_{00} + I_{01} + I_{10} + I_{11})$$

This is a measure of gate leakage of a logic gate during its steady state.





Gate Leakage in 2-input NAND (Transient Study)



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Gate Leakage in 2-input NOR (Transient Study)



Gate Leakage in Logic Gate (Transient Study)

 $C_{tun} \equiv$ Effective tunneling capacitance at the input of a logic gate





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Effect of Process and Design Parameter Variation





Gate Leakage in 2-input Logic Gates $(T_{ox} Variation)$







Gate Leakage in 2-input Logic Gates $(V_{DD} Variation)$







Observations





Gate Leakage in 2-input Logic Gates

- Both ON and OFF states contribute to gate leakage
- Transient effect is significant and can be captured via effective tunneling capacitance
- *I*_{tun} ≡ State Independent average gate leakage current of a logic gate
- $C_{tun} \equiv$ Effective tunneling capacitance at the input of a logic gate
- I_{tun} is larger for NOR
- C_{tun} is larger for NAND





Usefulness of the Proposed Metrics

- The metrics allow designers to account for gate tunneling effect in nano-CMOS based circuit designs.
- *I_{ON}* and *I_{OFF}* additive to static power consumption.
- C^{eff}_{tun} additive to intrinsic gate capacitance
 C_{logic} = C^{eff}_{tun} + C_{intrinsic}
 All three needs to be taken into account for
- All three needs to be taken into account for effective total (switching, subthreshold, gate leakage) power optimization





Estimation of Gate Leakage





Gate Leakage Estimation

- What we have observed?
 - Gate leakage is input state dependent
 - Gate leakage is dependent on position of ON/OFF transistors
 - Gate leakage is sensitive to process variation
- Gate leakage estimation methods for logic level description of the circuit:
 - Pattern dependent estimation (R. M. Rao ISLPED 2003)
 - Pattern independent probabilistic estimation (R. M. Rao ISLPED 2003)



Estimation: Pattern Dependent

- For an given input vector switch-level simulation is performed
- State of internal nodes is determined for the input vector
- Unit width gate leakage of a device is determined for different states
- The total gate leakage is computed by scaling the width of each device by unit-width leakage in that state and adding the individual leakages:

$$I_{ox} = \sum_{MOS} I_{ox,MOS}(s(i)) * W_{MOS}$$





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Source: R. M. Rao ISLPED2003

Estimation: Pattern Independent

- Probability analysis in conjunction with statedependent gate leakage estimation is used.
- The average gate leakage of the circuit is the probabilistic mean of the gate leakage of the circuit:

$$\begin{split} \mathsf{I}_{\mathsf{ox},\mathsf{avg}} &= \textit{E}(\Sigma_{\mathsf{MOS}} \ \mathsf{I}_{\mathsf{ox},\mathsf{MOS}}(\mathsf{s}(\mathsf{i})) * \mathsf{W}_{\mathsf{MOS}}) \\ &= \Sigma_{\mathsf{MOS}} \ \mathsf{W}_{\mathsf{MOS}} * \left(\ \Sigma_{\mathsf{j}} \ \mathsf{I}_{\mathsf{ox},\mathsf{MOS}}(\mathsf{s}(\mathsf{j})) * \mathsf{P}(\mathsf{j}) \right) \\ \text{where } \mathsf{P}(\mathsf{j}) \text{ is the probability of occurrence of state j.} \end{split}$$



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Source: R. M. Rao ISLPED2003



Estimation: Heuristic and Look-up Tables

- Interaction between gate leakage and subthreshold leakage are used to develop heuristic based estimation techniques for state-dependent total leakage current.
- Heuristics based on lookup tables are available to quickly estimate the state-dependent total leakage current for arbitrary circuit topologies.







Estimation: Loading Effect on leakage



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- Represent circuit as graph: vertex
 → logic gate and edge → net
- 2. Sort vertices in topological order and initialize leakage values to zero
- 3. Propagate input vector and assign a logic state to each gate
- 4. Calculate total input and output loading current due to gate leakage
- 5. Calculate the leakage of the individual logic gates
- 6. Compute the leakage of the total circuit by adding leakage of individual gates.

Source: Mukhopadhyay DATE2005 and TCAD 2005 (to appear)



Optimization of Gate Leakage





Techniques for Gate Leakage Reduction

Research in Gate leakage is catching up and have not matured like that of dynamic or subthreshold power. Few methods:

- Dual T_{OX} (Sultania DAC 2004, Sirisantana IEEE DTC Jan-Feb 2004)
- Dual K (Mukherjee ICCD 2005)
- Pin and Transistor Reordering (Sultania ICCD 2004, Lee DAC 2003)





Dual T_{OX} Technique: Basis

Gate oxide tunneling current I_{oxide} (k is a experimentally derived factors):

 $I_{oxide} \alpha (V_{dd} / T_{gate})^2 exp (-k T_{gate} / V_{dd})$

- Options for reduction of tunneling current:
 - Decreasing of supply voltage V_{dd} (*will play its role*)
 - Increasing gate SiO₂ thickness T_{oxide}



Dual T_{OX} Technique: Basis







Dual T_{OX} Technique: Approach

 Our approach – scale channel length (L) as well as T_{ox} ; T_{ox} is almost linearly scaled with L_{eff}



Advantages:

- Reduces DIBL effect
- Constant Input Gate Capacitance for a given W_{eff}









Dual T_{OX} Technique: Results

- Iterative algorithm that
 - Generates delay/leakage tradeoffs
 - Meets delay constraint
- For same delay an average leakage reduction of 83% compared to the case where all transistors are set to T_{ox-Lo}.
- Minor changes in design rules and an extra fabrication step is required, extra mask required.





Dual K Technique: Basis







Dual K Technique: Basis











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Dual K Technique: Basis (Example: Four Types of Logic Gates)

Assumption: all transistors of a logic gate are of same K_{qate} and equal T_{qate} .



Dual K Technique: Basis

Use of multiple dielectrics (denoted as K_{gate}) of multiple thickness (denoted as T_{gate}) will reduce the gate tunneling current significantly while maintaining the performance.

Source: Mukherjee ICCD 2005





Dual K Technique: New Dielectrics

- Silicon Oxynitride (SiO_xN_y) (K=5.7 for SiON)
- Silicon Nitride (Si₃N₄) (K=7)
- Oxides of :
 - Aluminum (AI), Titanium (Ti), Zirconium (Zr),
 Hafnium (Hf), Lanthanum (La), Yttrium (Y),
 Praseodymium (Pr),
 - their mixed oxides with SiO_2 and AI_2O_3
- NOTE: I_{gate} is still dependent on T_{gate} irrespective of dielectric material.



Dual K Technique: Strategy

- **Observation**: Tunneling current of logic gates increases and propagation delay decreases in the order K_2T_2 , K_2T_1 , K_1T_2 , and K_1T_1 (where, $K_1 < K_2$ and $T_1 < T_2$).
- Strategy: Assign a higher order K and T to a logic gate under consideration
 - To reduce tunneling current
 - Provided increase in path-delay does not violate the target delay

Source: Mukherjee ICCD 2005



Dual K Technique: Algorithm

- **Step 1:** Represent the network as a directed acyclic graph G(V, E).
- **Step 2:** Initialize each vertex $v \in G(V, E)$ with the values of tunneling current and delay for K_1T_1 assignment.
- **Step 3:** Find the set of all paths $P{\Pi_{in}}$ for all vertex in the set of primary inputs (Π_{in}) , leading to the primary outputs Π_{out} .

Step 4: Compute the delay D_P for each path *p* ∈ P{Π_{in}}. Source: Mukherjee ICCD 2005



Dual K Technique: Algorithm

Step 5: Find the critical path delay D_{CP} for K_1T_1 assignment.

Step 6: Mark the critical path(s) P_{CP} , where P_{CP} is subset $P{\Pi_{in}}$.

Step 7: Assign target delay $D_T = D_{CP}$.

Step 8: Traverse each node in the network and attempt to assign K-T in the order K_2T_2 , K_2T_1 , K_1T_2 , and K_1T_1 to reduce tunneling while maintaining performance.

Source: Mukherjee ICCD 2005



Dual K Technique: Characterization (How to Model High-K?)

 The effect of varying dielectric material was modeled by calculating an equivalent oxide thickness (T^{*}_{ox}) according to the formula:

 $T_{ox}^{*} = (K_{gate} / K_{ox}) T_{gate}$

• Here, K_{gate} is the dielectric constant of the gate dielectric material other than SiO₂, (of thickness T_{gate}), while K_{ox} is the dielectric constant of SiO₂.





Dual K Technique: Characterization

- The effect of varying oxide thickness T_{ox} was incorporated by varying TOXE in SPICE model.
- Length of the device is proportionately changed to minimize the impact of higher dielectric thickness on the device performance :

 $L^* = (T^*_{ox} / T_{ox}) L$

 Length and width of the transistors are chosen to maintain (W:L) ratio of (4:1) for NMOS and (8:1) for PMOS.





Dual K Technique: Characterization





Dual K Technique: Experimental Setup

- DKDT algorithm integrated with SIS, and tested on the ISCAS'85 benchmarks.
- Used $K_1 = 3.9$ (for SiO₂), $K_2 = 5.7$ (for SiON), $T_1 = 1.4$ nm, and $T_2 = 1.7$ nm for our experiments.
- T₁ is chosen as the default value from the BSIM4.4.0 model card and value of T₂ is intuitively chosen

Source: Mukherjee ICCD 2005





Dual K Technique: Experimental Results

Tunneling Current and % Reduction



Benchmark Circuits Source: Mukherjee ICCD 2005

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Pin Reordering with Dual-Tox

A key difference between the state dependence of I_{sub} and I_{qate}

- I_{sub} primarily depends on the number of OFF in stack
- I_{gate} depends strongly on the position of ON/OFF transistors



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